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Docket No.: 070759-0033

**PATENT**

**Reply Under 37 CFR 1.116 - Expedited Procedure - Technology Center 2800**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Masashi WATANABE, et al.

Application No.: 10/531,391

Customer No.: 20277

Filed: April 15, 2005

Confirmation No.: 6874

Group Art Unit: 2828

Examiner: Xinning Niu

Title: SEMICONDUCTOR LASER DEVICE

**RESPONSE UNDER 37 CFR § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Reconsideration of the rejection imposed in the Office Action dated June 5, 2009, is solicited in light of the following Remarks.

**Remarks** begin on page 2 of this paper.